

#### UNITED STATES DEPARTMENT OF COMMERCE

### Patent and Trademark Office

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P. O. Box 1450

Alexandria, VA 22313-1450

SERIAL NUMBER	FILING DATE	FIRST NAMED APPLICANT	ATTORNEY DOCKET NO.
10/663,981	09/17/2003	JungWan KO	1293.1966

EXAMINER Jorge L. Ortiz Criado ART PAPER UNIT NUMBER 2627

Date:

08/07/2008

To:

Seth S. Kim

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### **RESPONSE TO STATUS INQUIRY**

(Transmitted by facsimile - no cover sheet)

In response to your communication filed on 07/15/2008.

The most recent status/action on the above identified application is:

- 1. The above identified application has been assigned a patent number with an issue date of
- 2. Your application is currently being processed in:

Initial Data Capture

File Maintenance

Final Data Capture

Comments: Your application was remanded back to the Technology Center awaiting your examiner response to the 312 amendment dated 05/02/2008.

If you have any questions, you may contact the Office of Data Management's Application Assistance Unit on 571-272-4200 or by facsimile on 703-308-5065.

Roxanne Rawls Contact Representative, Application Assistance Unit Office of Data Management

Docket No.: 1293.1966

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Jung-Wan KO et al.

Application No. 10/663,981

Group Art Unit: 2627

Confirmation No. 1954

Filed: September 17, 2003

Examiner: Jorge L. Ortiz Criado

For:

METHOD OF AND APPARATUS FOR MANAGING DISC DEFECTS IN DISC, AND

DISC ON WHICH DEFECTS ARE MANAGED

# LETTER TO THE EXAMINER REQUESTING STATUS OF APPLICATION

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

Further to a review of the Patent Application Information Retrieval (PAIR) system, it is noted that applicants paid the issue fee on May 9, 2008. However, the application has not issued as a patent. Further, an Amendment under 37 CFR § 1.312 was filed on May 2, 2008, but the status thereof has not been communicated to the undersigned. As such, applicants respectfully request the status of the application, entry of the Amendment under 37 CFR § 1.312, and issue of the patent in timely fashion.

Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date

Bv:

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